

**Search Notes**

Application/Control No.

10/774,496

Examiner

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Applicant(s)/Patent under  
Reexamination

IBA, YOSHIHISA

Art Unit

2813

**SEARCHED**

Class	Subclass	Date	Examiner
438	622	11/6/2006	JC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
pgpub	txt clm	11/6/2006	JC

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
east updated	11/6/2006	JC